

PATENT APPLICATION  
Docket No. 9903-041  
Client No. S01US012

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JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Sung-Muk LIM, et al.

Serial No. 10/027,639

Examiner: Trail, Allyson Neel

Confirmation No. 1485

Filed: December 19, 2001

Art Unit: 2876

For: METHOD AND APPARATUS FOR DETECTING DEFECTIVE  
MAKINGS ON A SEMICONDUCTOR PRODUCT

Mail Stop AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Responsive to the Office Action dated April 20, 2004, enclosed is an amendment in the  
above-identified application.

The fee has been calculated as shown below.

CLAIMS AS AMENDED					
For:	Number After Amendment	Previous Number	Extra	Rate	Additional Fee
Total Claims	27	26	0	x \$18 =	\$18.00
Independent Claims	5	5	0	x \$86 =	\$0.00
Extension of Time -- 1 <sup>st</sup>					\$110.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$128.00

- ☒ PTO Form 2038 authorizing credit card payment of \$128.00, extra claim fee (\$18.00) and  
extension fee (\$110.00) is enclosed.
- ☒ Any deficiency or overpayment should be charged or credited to deposit account number 13-  
1703.

Customer No. 20575

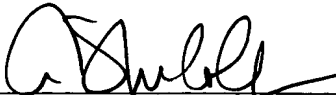
Respectfully submitted,

MARGER JOHNSON & McCOLLOM, P.C.

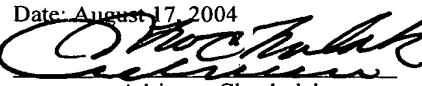
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Alan T. McCollom  
Reg. No. 28,881

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P.O. Box 1450, Alexandria, VA 22313-  
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Date: August 17, 2004  
  
Adrienne Chocholak



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MAKINGS ON A SEMICONDUCTOR PRODUCT

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Responsive to the Office Action, dated April 20, 2004, please amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.

/25/2004 FFANAI2 00000033 10027639

FC:1202

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